



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: DAVID A. PALSULICH ET AL.
APPLICATION No.: 10/636,021
FILED: AUGUST 6, 2003
FOR: **MICROFEATURE WORKPIECE
PROCESSING SYSTEM FOR, E.G.,
SEMICONDUCTOR WAFER ANALYSIS**

EXAMINER: ERIC B. CHEN
ART UNIT: 1765
CONF. No: 1017

Amendment Under 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated May 9, 2005 in the above-identified application. Please extend the period of time for response to this Office Action by one month, to expire September 9, 2005. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.